

AS-FILED DRAWINGS W/ANNOTATIONS

Inventor: Gilyong Chung, et al.

Docket No.: 14506-44054

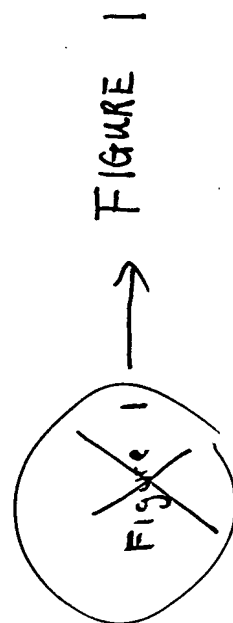
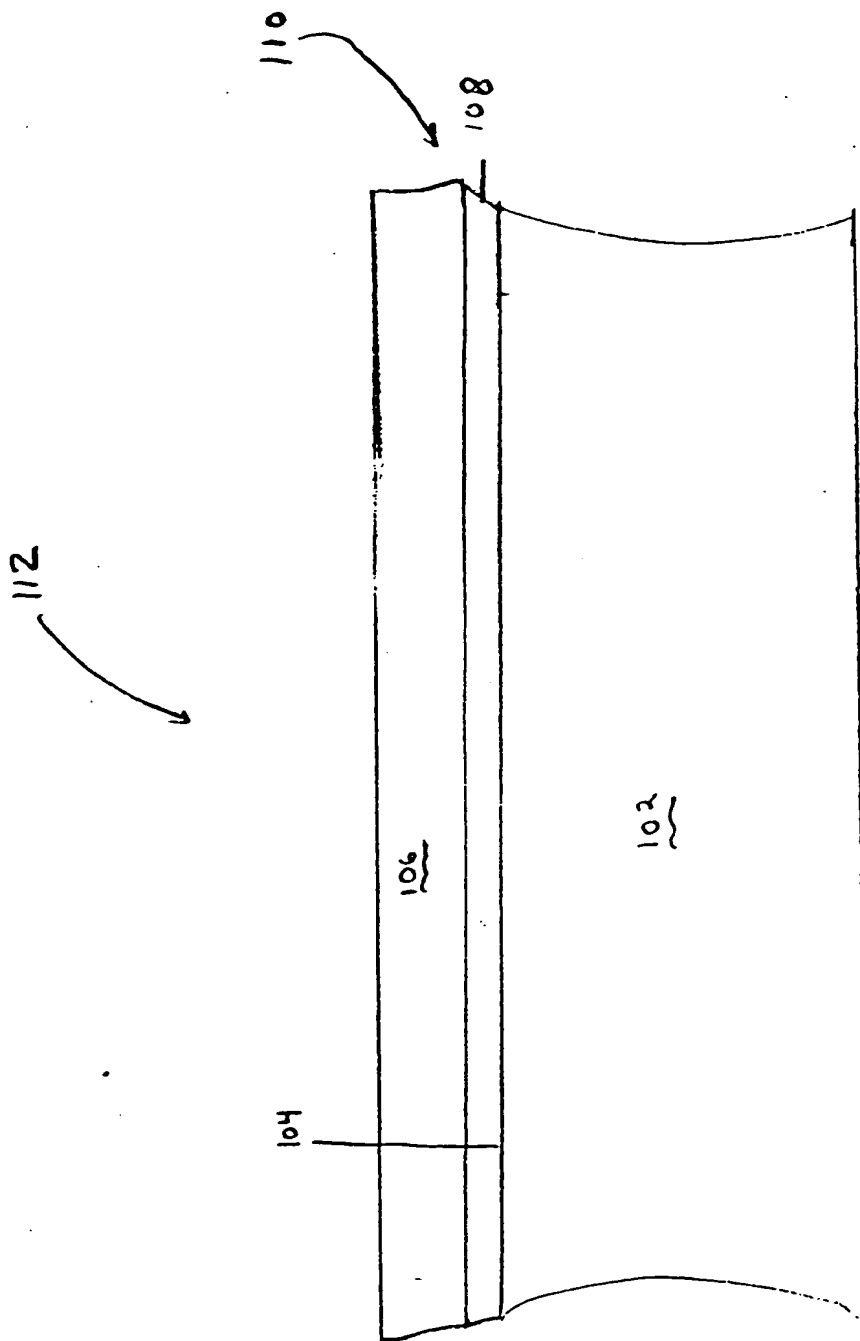
Title: Inclusion of Nitrogen At the Silicon Dioxide-Silicon

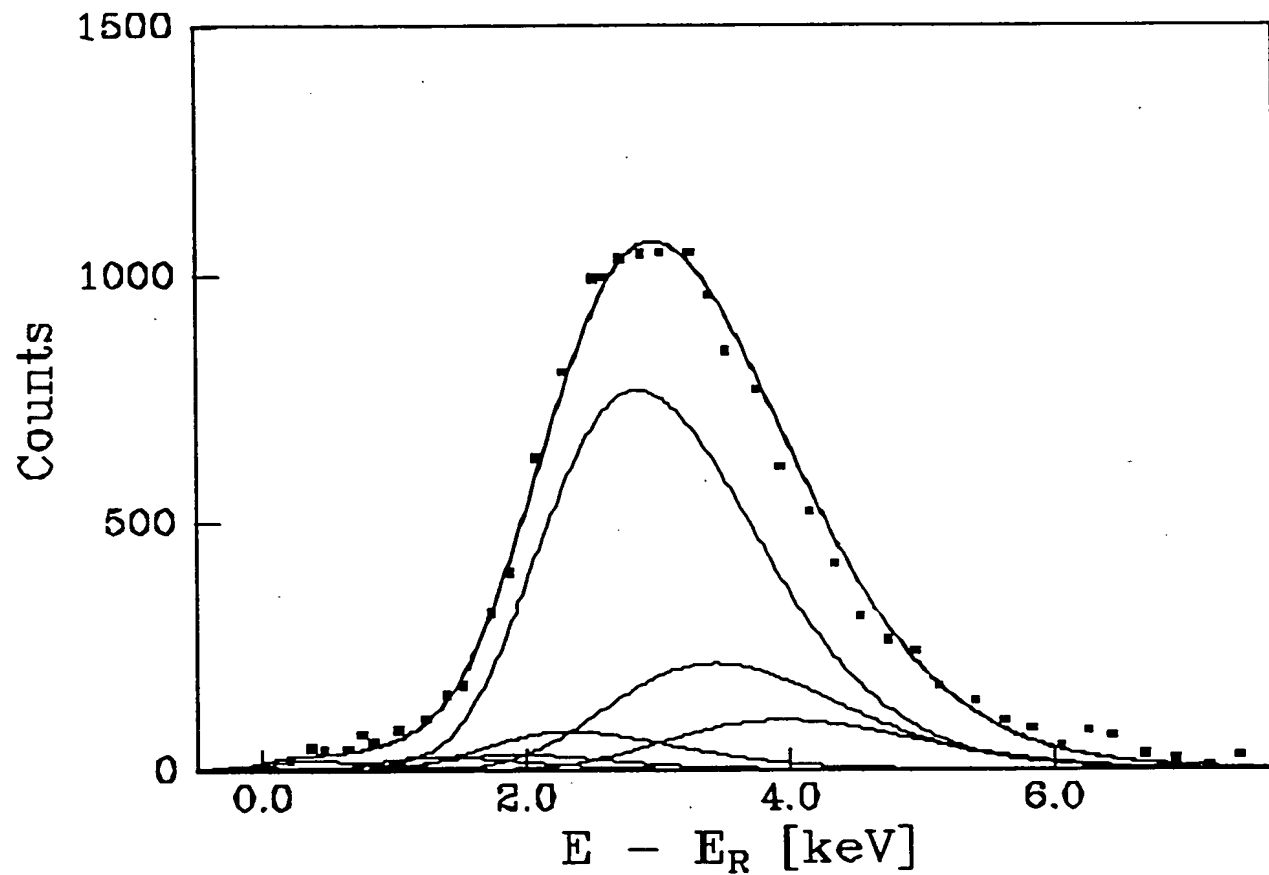
Carbide Interface for Passivation of Interface Defects

Serial No. 09/818,193

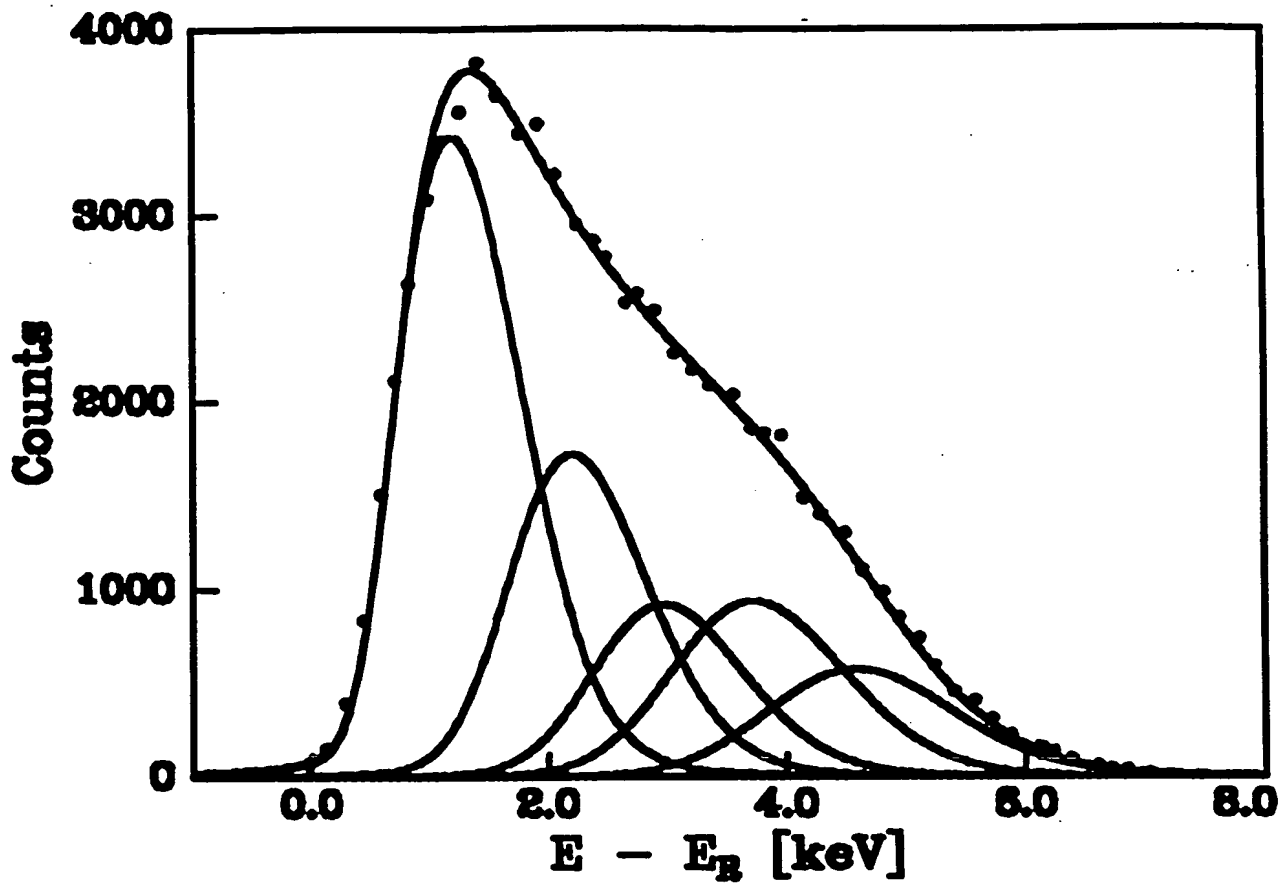
Attorney Name: Tim Tingkang Xia

Phone No.: 404-495-3678 Sheet 1 of 6

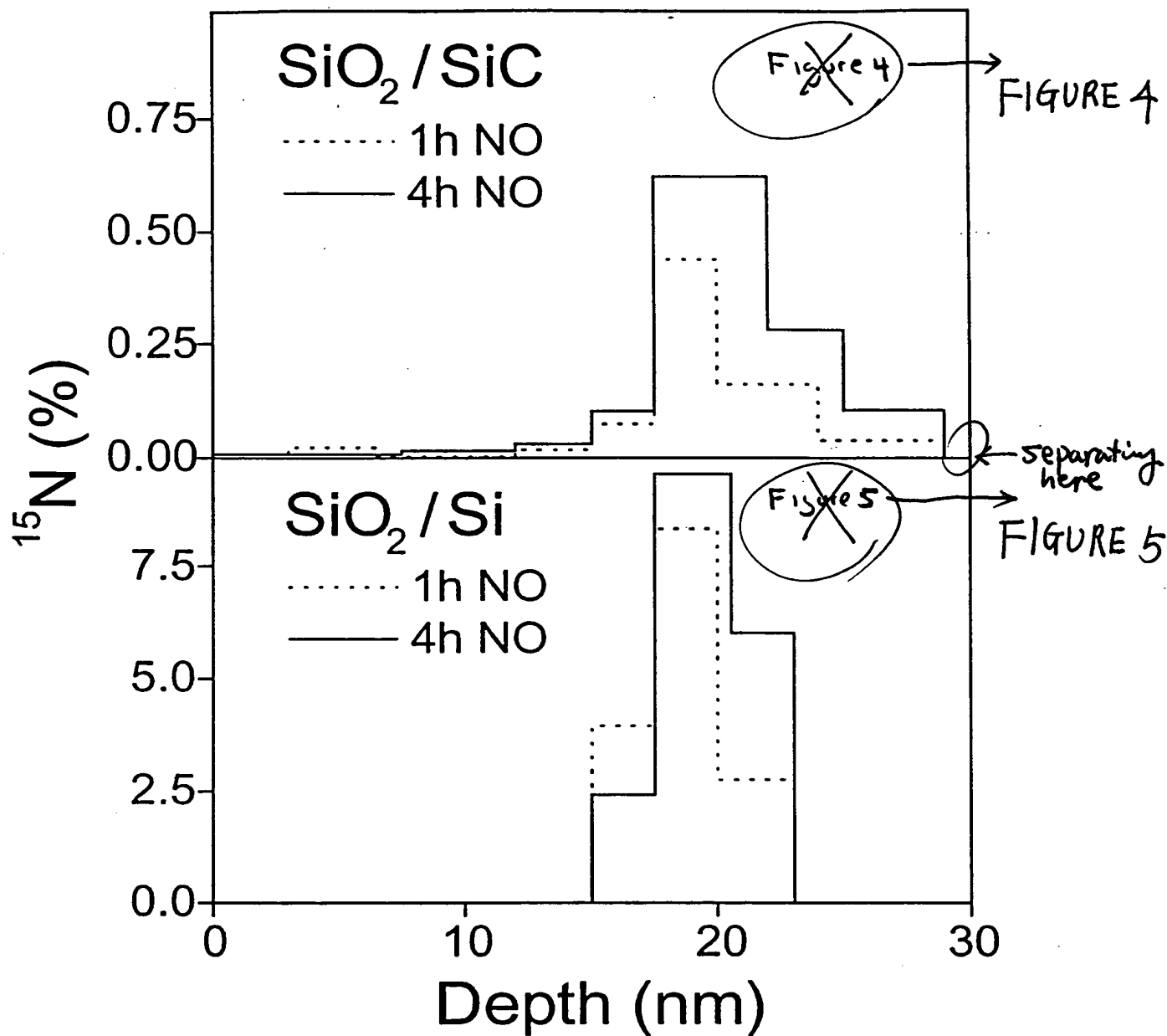


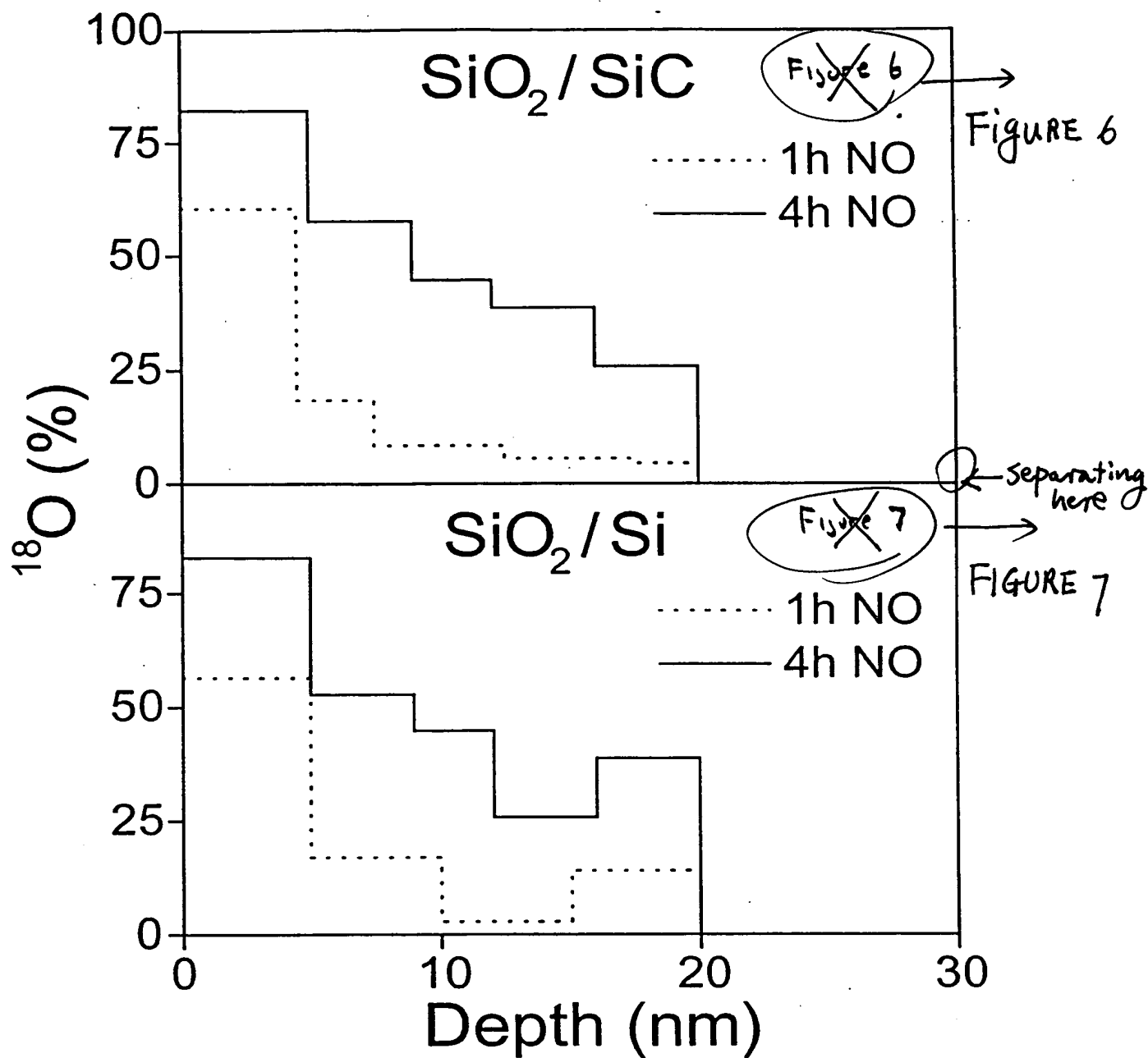


~~Figure 2~~ → FIGURE 2



~~Figure 3~~ → FIGURE 3





~~Figure 8~~ → FIGURE 8

